

Form PTO-1449		ATTY DOCKET NO. 04202	APPLICATION NO. 10/512,077			
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		APPLICANT Olivier Marty et al.				
(Use several sheets if necessary)		FILING DATE November 5, 2004	GROUP			
U. S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	TRANSLATION	
GNR	10 2 5 8 2 7 3	3/00	EP Abstract		YES	NO
GNR	2 6 8 9 9 1 2	10/93	FR w/Abstract			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
	GNR	Romanov et al, "GeSi Films With Reduced Dislocation Density Grown by Molecular-Beam Epitaxy on compliant Substrates Based on Porous Silicon" Applied Physics Letter, etc., Vol. 75, No. 26, Dec. 27, 1999, pp 4118-4120.				
		Sanchez et al, "Structural and Morphological Characteristics of InGaAs/GaAs Quantum Well Structures on Tilted (111)BGaAs Grown by MBE", Journal of Crystal Growth etc., Vol. 192, No. 3-4, Sept. 1, 1998, pp 363-371.				
EXAMINER		DATE CONSIDERED 11/07/07				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.